



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Christoph A. Wasshuber
Filing Date: November 13, 2003
Serial No.: 10/714,366
Group Art Unit: Unknown
Title: *Forming a Semiconductor Structure in Manufacturing a Semiconductor Device Using One or More Epitaxial Growth Processes*

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Roseanne Cisneros de Chairez, PLS

Roseanne Cisneros de Chairez, PLS

Date: May 10, 2004

INFORMATION DISCLOSURE STATEMENT

Applicant respectfully requests, pursuant to 37 C.F.R. §§ 1.56, 1.97, and 1.98, that the documents listed on the attached PTO-1449 form be considered and cited in the examination of the above-identified patent application. Copies of these documents are enclosed for the convenience of the Examiner. Furthermore, no representation is made that a search has been made, that these documents are material to the patentability of the present invention, or that these documents qualify as prior art.

This Information Disclosure Statement is submitted before the mailing of a first Office Action on the merits, and therefore, pursuant to 37 C.F.R. § 1.97(b), no fee is believed to be due. If, however, a fee is due, the Commissioner is authorized to charge such fee to Deposit Account No. 20-0668 of TEXAS INSTRUMENTS INCORPORATED.

BAKER BOTTS L.L.P.
Attorneys for Applicant



Christopher W. Kennerly
Reg. No. 40,675

Date: May 6, 2004

Correspondence Address:

23494

Patent Trademark Office



PTO-1449

**Information Disclosure Citation
in an Application**Application No.
10/714,366Applicant(s)
Christoph A. WasshuberDocket Number
TI-36280
(032350.B536)Group Art Unit
UnknownFiling Date
November 13, 2003**U.S. PATENT DOCUMENTS**

		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	A	US 2003/0104222 A1	06/05/2003	Ono et al.	428	446	09/18/2002
	B	US 6,727,567 B2	04/27/2004	Bastek et al.	257	506	03/05/2002
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FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	P							
	Q							
	R							
	S							

NON-PATENT DOCUMENTS

		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
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EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.